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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:

Robert A. Bellman et al.

Serial No:

10/722,769

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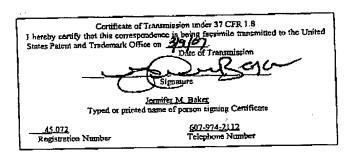
Title:

METHOD USING MULTI-COMPONENT COLLOIDAL ABRASIVES

FOR CMP PROCESSING OF SEMICONDUCTOR AND OPTICAL

MATERIALS

Mail Stop RCE Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450



## AMENDMENT AND REQUEST FOR RECONSIDERATION

Sir:

In reply to the February 6, 2007, Decision by the Board of Patent Appeals and Interferences in the above-referenced application, please enter the following Request for Continuing Examination and amendments to the Claims, and consider the accompanying remarks.

If any additional fees for the accompanying response are required, Applicants respectfully request that this be considered a petition therefor. Applicants hereby authorize the Office to charge any necessary fees or surcharge that may be required to Deposit Account 03-3325.

Amendments to the Claims are reflected in the Listing of Claims that begins on page 2 of this paper; and

Remarks begin on page 9 of this paper.